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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/987,113	11.13.2001	Junichi Taniguchi	D-1172	6453
75	90 02 13 2003			
KANESAKA AND TAKEUCHI			EXAMINER	
1423 Powhatan Street Alexandria, VA 22314			GURZO, PAUL M	
			ART UNIT	PAPER NUMBER
*			2881	
			DATE MAILED: 02/13/2003	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
· · · · · · · · · · · · · · · · · · ·	09/987,113	TANIGUCHI, JUNICHI				
Office Action Summary	Examiner	Art Unit				
	Paul Gurzo	2881				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply 1 kNO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute. - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be ting within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely the mailing date of this communication. D (35 U S.C. § 133)				
Status						
1) Responsive to communication(s) filed on	— · is action is non-final.					
		recognition as to the marite is				
3) Since this application is in condition for allows closed in accordance with the practice under Disposition of Claims	Ex parte Quayle, 1935 C.D. 11, 4	153 O.G. 213.				
4)[·] Claim(s) 1-10 is/are pending in the application	1.					
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6) Claim(s) 1-10 is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/o	r election requirement.					
Application Papers						
9) The specification is objected to by the Examine	er.					
10) The drawing(s) filed on 13 November 2001 is/a		to by the Examiner.				
Applicant may not request that any objection to the						
11) The proposed drawing correction filed on						
If approved, corrected drawings are required in re	ply to this Office action.					
12) The oath or declaration is objected to by the Ex	caminer.					
Priority under 35 U.S.C. §§ 119 and 120						
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).						
a)⊠ All b) Some * c) None of:						
1. Certified copies of the priority document	ts have been received.					
2. Certified copies of the priority documen	ts have been received in Applicat	ion No				
 Copies of the certified copies of the prical companies of the prical copies. See the attached detailed Office action for a list 	ıreau (PCT Rule 17.2(a)).					
14) Acknowledgment is made of a claim for domest	ic priority under 35 U.S.C. § 119(e) (to a provisional application).				
a) The translation of the foreign language pr	ovisional application has been re	ceived.				
Attachment(s)	•					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Informal	ry (PTO-413) Paper No(s) Patent Application (PTO-152)				
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Art Unit: 2881

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1 and 5-9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Douglas (5,179,278) and further in view of Bier (5,750,993).

Regarding claim 1, Douglas teaches an ion trap mass spectrometer comprising an ion supply source (12) and an ion storing section (44) disposed between the ions supply source and the ion trap (58) providing an RF electric field (col. 2, lines 43-44 and Fig. 1) with an axial electric potential (col. 4, lines 46-49). He also teaches applying a high voltage on the plate (40), which will subsequently act as an entrance gate electrode (col. 4, lines 36-38) for introducing the ions. He also teaches applying another voltage on the plate (52) (col. 4, lines 34-36), which will subsequently act as an exit gate electrode for emitting the ions to the ion trap (58). He teaches that these two plates will reflect the ions back and forth and will also reject unwanted ions (col. 5, lines 55-67). These steps are controlled by a controller (71) (col. 4, lines 23-28).

Douglas does not teach the step of controlling the RF voltage to the ion trap, but it would be obvious to control this trap as is known in the art as taught by Bier. Bier teaches the after introduction of ions into the ion trap, the RF voltage is applied to the trap (col. 3, lines 17-19). He teaches that the ions can be blocked by applying a low RF voltage (col. 3, lines 28-30). This teaches on the claimed cutoff of RF voltage. Further, the act of suddenly applying the RF

Art Unit: 2881

voltage to retain the ions is considered obvious to the teachings because an RF voltage is needed for the ion trap to operate successfully. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to apply the desired voltages to the ion trap because these voltages will ensure that the ion trap will store the proper amount of desired ions for the purpose of spectrometry.

Regarding claim 5, Douglas teaches the use of an ion lens (56) disposed between the exit gate electrode and the ion trap (col. 2, lines 52-56 and Fig. 1).

Regarding claims 6 and 7, Douglas teaches the control means connected to the gate electrodes and storing section, and Bier teaches controlling the ion trap as described above. Further, it is considered obvious that since the gate electrodes are receiving a voltage that they are able to open and close to promote the desired storing and subsequent releasing into the ion trap. Douglas teaches this claimed closing of the exit electrode (col. 4, lines 31-34). He also teaches rejecting ions of unwanted mass (col. 5, lines 55-67).

Regarding claims 8 and 9, Douglas teaches that unwanted ions are ejected by means of an RF voltage (which will produce an RF electric field) (col. 5, lines 55-67). These ions will be excluded from the storing section before they are introduced into the ion trap. Further, the application of an RF electric field is considered obvious in view of Douglas. These unwanted ions are rejected and will not be collected for introduction to the ion trap (col. 6, lines 62-67).

Claims 2, 3, and 10 are rejected under 35 U.S.C. 103(a) as being unpatentable over Douglas (5,179,278), in view of Bier (5,750,993), and further in view of Baba et al. (5,783,824).

Regarding claim 2, the above-applied prior art does not explicitly teach the use of resistors in connection with multipole electrodes. However, Baba et al. teach that the electrodes

Art Unit: 2881

(63') are connected to resistors with an appropriate resistance (R) (col. 9, lines 53-61, col. 18, lines 24-45, col. 21, lines 15-37, and Fig. 12). This connection reads on the claim that the electrodes are formed of a resistor. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to use resistors with the multipole electrode design so that ions are resonantly oscillated along the direction of the central axis of the electrode structure.

Regarding claim 3, Baba et al. depict the claimed plural sections divided in a longitudinal direction (Fig. 12) and teach the independent application of DC voltages (col. 15, lines 49-55).

Regarding claim 10, Baba et al. teach the cooling of the ions by collisions with helium gas (col. 16, lines 42-52). Though they teach this cooling in the ion trap itself, it is known that cooling is prevalent in the art, and this teaching can be extended to include cooling in the storing section instead of the ion trap.

Claim 4 is rejected under 35 U.S.C. 103(a) as being unpatentable over Douglas (5,179,278), in view of Bier (5,750,993), and further in view of Smith et al. (6,107,628).

The above-applied prior art does not explicitly teach a plurality of annular electrodes with an independent application of DC and RF voltages. However, Smith et al. teach that RF voltages are applied to the annular rings (col. 3, lines 24-38) and a DC voltage supply (350) provides a voltage that is fed to each of the rings (col. 10, lines 20-23 and Fig. 3). Fig. 3 clearly depicts that claimed independent application of the DC voltage and the RF voltage application will act in the much the same manner. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to use this independent application because it help to define the proper confinement zone for the ions as they travel.

Art Unit: 2881

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Paul Gurzo whose telephone number is (703) 306-0532. The examiner can normally be reached on M-Thurs. 7:30 - 6:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Lee can be reached on (703) 308-4116. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9318 for regular communications and (703) 872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

PMG January 27, 2003

SUPERVISCILY 6